# PULSED LASER DEPOSITION OF THIN FILMS

Douglas B. Chrisey and Graham K. Hubler (1994)

- Success of Pulsed Laser Deposition has far outpaced understand of laser ablation process, at least in the range of laser energies used for film growth ( $\sim 50 MW \, cm^{-2}$ )
- Requires diagnostics with ~ 1 nanosecond speed
- Requires in situ diagnostics to correlate gas-phase conditions with film properties
- We want to be able to measure various state variables of the plasma (Temperature, Density) as well as ionization states and behavior of the various species in the plasma
- Here we will utilize gas-phase diagnostics to attempt to characterize the formation, propagation, and properties of plasma plumes typically seen in a PLD apparatus

- Various diagnostic techniques are better suited for high or low density plasma plumes
- Each diagnostic may only one or two components of the plasma plume (monoatomic atoms and ions, molecules, clusters, particles, etc)
- Understanding of PLD plasma and diagnostics primarily derived from prior experimental and theoretical research in higher laser power density regimes (>  $1\,GW\,cm^{-2}$ ) as a result of laser fusion research (as of 1994)

Various major unresolved question about PLD plasma plumes (1994) include (but are not limited to)

- Role of electronic and thermal sputtering mechanisms in the ablation of material amounts necessary for film growth
- Extent and explanation of laser absorption by initial ejectants (atoms or clusters/flakes of sputtered material)
- Etching effects of laser plasma on the target
- Expansion mechanism(s) responsible for unexpected high kinetic energy of ejectants; i.e., the competition between adiabatic expansion of the plasma and space charge acceleration models

- Fractional ionization of the plasma plume and the extent to which it can be electromagnetically steered
- Roles of diffusion, scattering and hydrodynamics in the slowing and thermalization of the plume by background gases.
- Factors governing the optimal film growth for various materials (kinetic energy, deposition rate, etc)
- The role of chemistry with the background gas
- Would altering the target surface morphology and phase have any affect on the ejecta?

Saha Equation- Describes ionization state of a plasma in local thermodynamic equilibrium (LTE)

$$\frac{(n_{i+1})n_e}{n_i} = \frac{2g_{i+1}}{\Lambda^3 g_i} e^{\left[\frac{\epsilon_{i+1} - \epsilon_i}{k_B T}\right]}$$

 $n_{i+1} = number \ density \ of \ the \ (i+1) \ ions \ (cm^{-3})$ 

 $n_{i+1} = number\ density\ of\ the\ (i)\ ions\ (cm^{-3})$ 

 $n_e = electron\ number\ density \qquad (cm^{-3})$ 

 $g_{i+1} = degeneracy states for the (i + 1) ions$ 

gi = degeneracy of states for the (i)ions

 $\Lambda$  = Thermal de Broglie wavelength of the electrons

 $\epsilon_{i+1} = ionization potential of the (i + 1)ions$ 

 $\epsilon_i$  = ionization potential of the (i)ions

$$\Lambda = \sqrt{\frac{h^2}{2\pi m_e k_b T}}$$

 $k_B = Boltzmann constant$ 

T = Temperature(K)

 $m_e = \text{mass of electron}$ 

h = Planck's constant

Simplified to

$$\frac{n_i}{n_n} = 2.4 \times 10^{15} \frac{T^{3/2}}{n_i} e^{-U_i/kT}$$

For the ratio of singly charged ions to neutrals in a plasma, and a fractional ionization of

$$\frac{n_i}{(n_n + n_i)}$$

Example: in a plasma of  $10^{14}$  atoms with  $U_i = 7 \ eV$  in an Ablation volume of

$$Av\Delta t = (0.04 \ cm^2) \left(10^6 \frac{cm}{s}\right) (50 \ ns) = 0.002 \ cm^3$$
 ,  $n_n = 5x10^{16} \ cm^{-3}$ 

The fractional ionization would be ~0.0001 for T~3000K but rises to ~0.80 at T~10000K

- The heating of a gas to the these temperatures is thought to occur through the inverse-Bremsstrahlung absorption of laser light in a free-free transition of electron-ion pairs
- Basically means that photons impact and accelerate ions/electrons in plasma?
- Absorption coefficient

$$\alpha = (3.69x10^8) \frac{Z^3 n_i^2}{T^{1/2} f^3} (1 - e^{-hf/kT}) \quad (in \ cm^{-1})$$

- Significant absorption requires  $n_i \sim 10^{19} cm^{-3}$ . This model also predicts better absorption at longer wavelengths.
- Example: with a KrF laser (hf=5eV), T=5000K, average charge Z=1, path length of 0.05cm, and  $v\Delta t \sim (\frac{10^6 cm}{s})(50ns)$ , a 1% absorption would require  $\alpha=.2~1/cm$  and an average ion density of  $n_i \sim 8x 10^{18} cm^{-3}$ . But for  $10^{15}$  released in a pulse of beam area  $0.04~cm^2$ , this number density can only exist for distances < 0.003~cm

- Shows the need for dynamic modeling of combined thermal, radiative, plasma and hydrodynamic phenomena with time step sizes << 1 ns.
- Since  $\alpha \propto n_i^2$ , spatially non-uniform beams may introduce localized hot spots in plumes
- Photoionization and dissociation of clusters may be important absorption processes

- A ~30ns PLD laser pulse in vacuum therefore produces a high pressure (~10-500 atm) bubble of hot plasma  $\leq 50 \mu m$  from the target.
- Expansion of this bubble modeled by fluid dynamics and hydrodynamic effects covered in Chp 3
- Expansion produces a supersonic 'beam' vaguely similar to a jet nozzle
- Angular distribution of the 'beam' is different for each species of the plasma plume
- Can lead to stoichiometry variations on the deposited film

- Electrons more mobile than ions or neutrals, but cannot escape plasma
- Due to strong space-charge field generated by moving away from the ions
- Leads to space-charge acceleration model for ions in the plume
- Electric field produced by electrons at plume boundary accelerate ions according to their charge
- Time of Flight (TOF) data substantiates this model
- Multiply charged ions travel faster than singly charged ions or neutral atoms
- Fast neutral atoms can be explained by recombination of the ions with electrons and/or resonant charge exchange between fast ions and slow neutrals

- Electrons in the plasma also respond quickly to internal or external potentials
- Form a "sheath" that shields the majority of the plasma from the applied field
- We can define the Debye length as a measure of this shield distance

$$\lambda_D = \left(\frac{kT_e}{4\pi n_e e^2}\right)^{1/2} = 6.9 \left(\frac{T_e}{n_e}\right)^{1/2} \text{ cm} \quad \text{[for } T_e \text{ in K]}$$

$$740 \left(\frac{kT_e}{n_e}\right)^{1/2} \text{ cm} \quad \text{[for kT in eV]}$$

- Even after expansion of plasma plume, shielding effect is still significant; after expanding to  $n_e \sim 10^8 cm^{-3}$  and cooling to  $kT_e \sim 0.01~eV$ , plasma will still have a  $\lambda_D \sim 25 \mu m$
- Attempts to steer or strip plume with fields will only penetrate a layer of the plume ~  $\lambda_D$

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$$\alpha = (3.69x10^8) \frac{Z^3 n_i^2}{T^{1/2} f^3} (1 - e^{-hf/kT})$$

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